

# Laser Power and Pulse Energy

	Micro-Pulse	Gun			Laser necessary		Laser project	
		Q.E.	$Q_{\text{bunch}}$	$I_{\text{mean}}$	$P_{\text{mean}}$	$E_{\text{pulse}}$	$P_{\text{mean}}$	$E_{\text{pulse}}$
ELBE nominal	13 MHz	1%	77 pC	1 mA	0.47 W	36 nJ	0.8 W	60 nJ
high bunch charge	1 MHz	1%	1 nC	1 mA	0.47 W	470 nJ	1.0 W	1 $\mu$ J

# Cs<sub>2</sub>Te cathode requirements

parameter	previously	necessary	international
Q.E.	0.2-0.5 %	>1 %	>4.5 %
Life time	?	1.2 kC 330 h @ 1mA (8 weeks)	1.2 kC 450 h @ 750 μA
Dark current	Small		wie Cu
average current density		32 mA/cm <sup>2</sup> @ r = 1 mm	21 mA/cm <sup>2</sup>
damage by Laser		32 W/cm <sup>2</sup> @ r = 1 mm	6 W/cm <sup>2</sup>
heat load		1 W	
electric field strength	22 MV/m	50 MV/m	125 MV/m

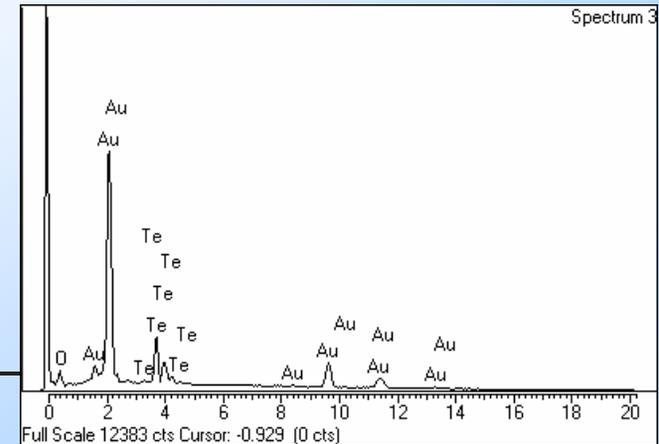
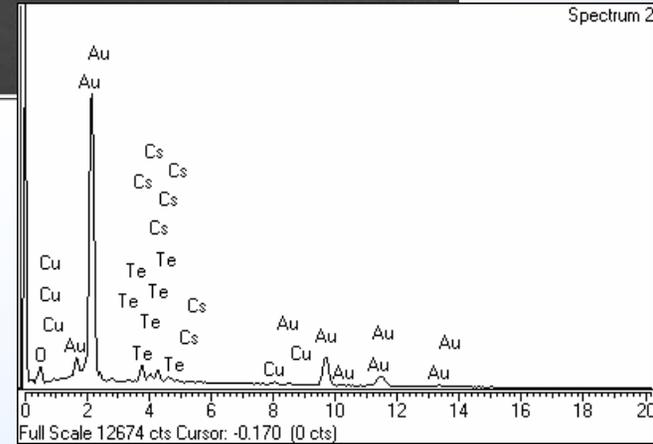
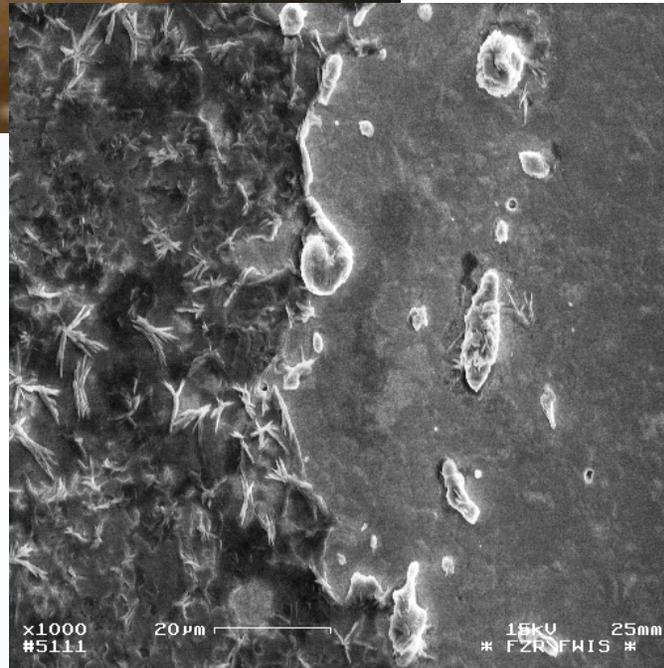
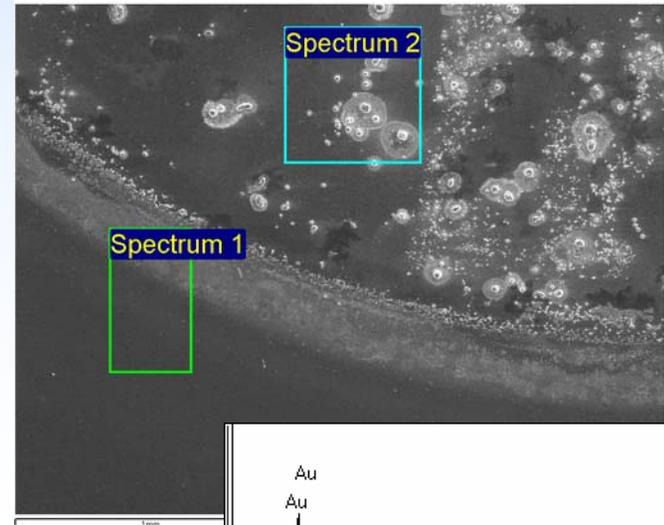
# problems with the first SRF-Gun

transfer of cathode into the gun-resonator was very difficult,  
specialist needed

Only one cathode available, whether good or not

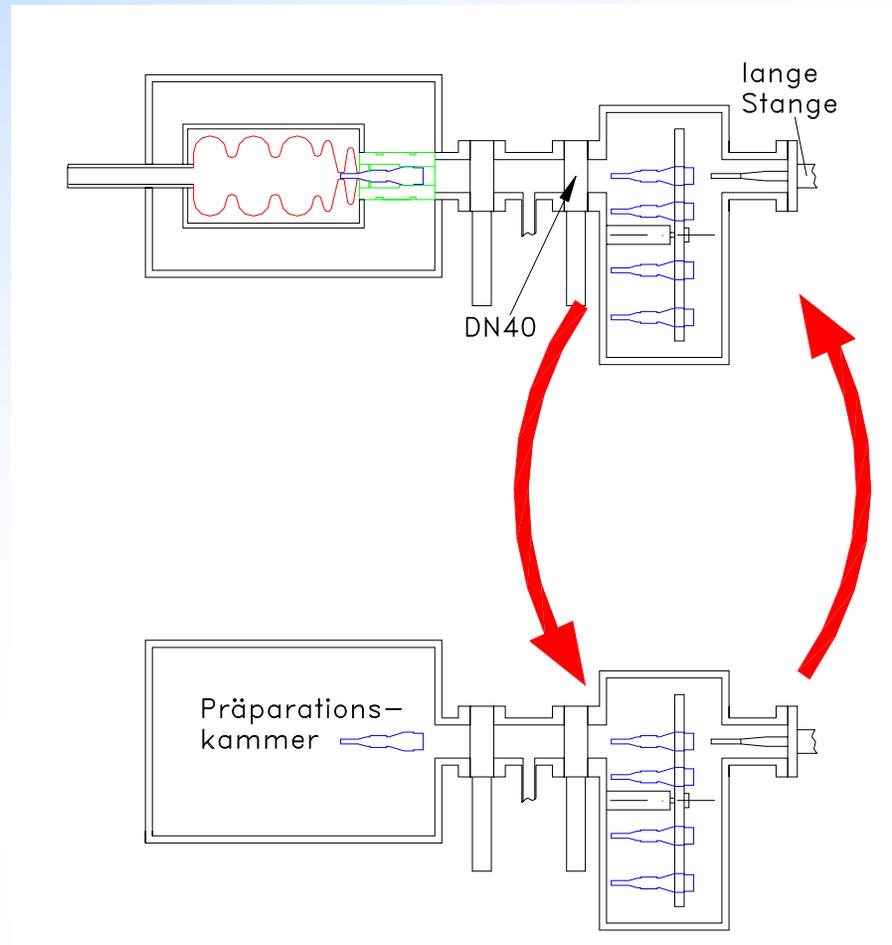
quality of cathodes:  
small quantum efficiency,  
inhomogeneous photo layers,  
position failures during deposition.

Präparation chamber:  
bad vacuum during evaporation,  
Bad mechanical adjustment,  
Unfavourable evaporators,  
evaporation process not reproduceable



**Strahlungsquelle ELBE**

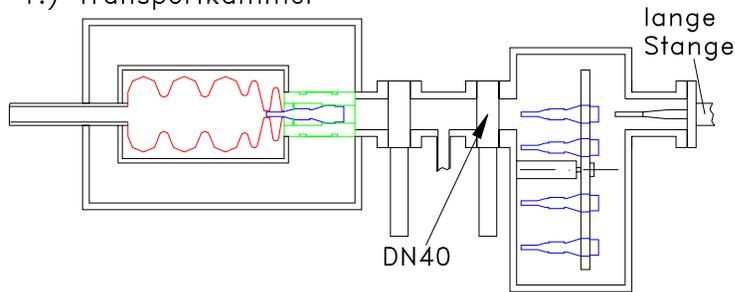
# Logistics and Transportation Chamber



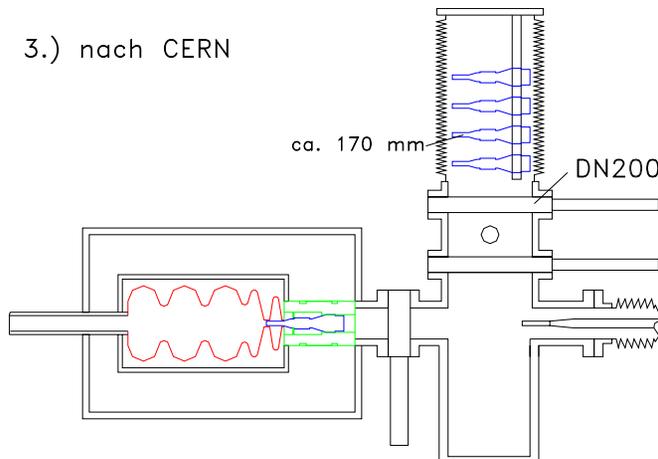
Advantage:

Cathode need not moved through the chamber

1.) Transportkammer



3.) nach CERN



2 transportation chambers with ion pumps

drawback:

long translator rod (1.2 m)

open questions:

Short transfer path length

precise movement

into the cavity

additional manipulator

and exchange chamber ?

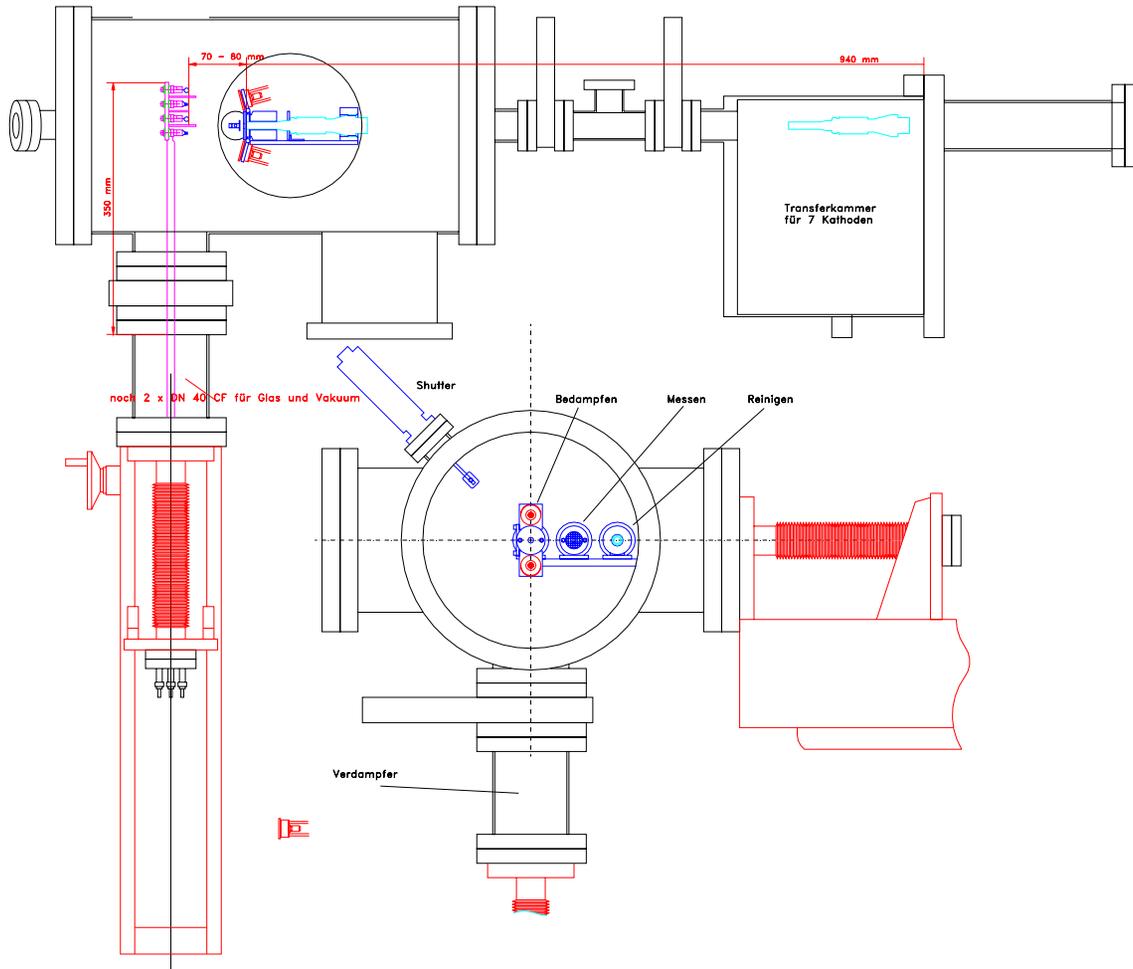
Modifications:

DN40,

More compact,

High precision translator

# Preparation Chamber



Open the chamber for  
modification or repair  
only  
Cathode and  
evaporator exchange  
using valves without  
mechanical accuracy  
of all components

# Functions

- cathode exchange
- vacuum generation and measurement
- evaporation of Te and Cs
- Measurement of quantum efficiency
  - Laser scan
  - collection electrode with homogenous electric field
  - cathode mounting (thread)
- Ion beam cleaning
  - cathode fitting
  - ion source
- Additional possibilities? Diagnostics ?

# Cs<sub>2</sub>Te layer preparation technology

## Up to now:

first Te evaporation, ca. 20 nm

then Cs up to maximum photo current (10 nm ?)

## New:

Te and Cs simultaneously

Co-evaporation

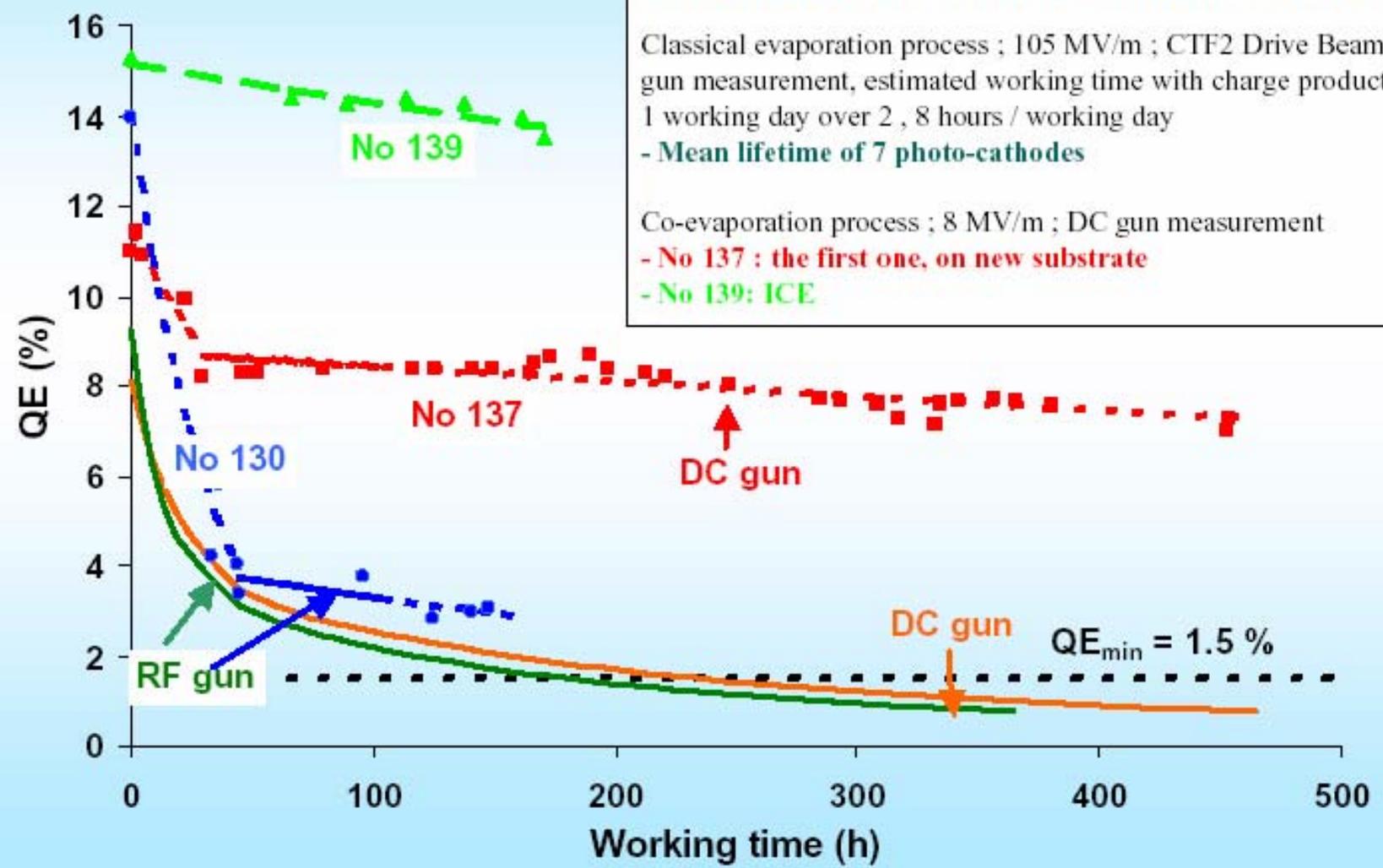


# Gain in QE

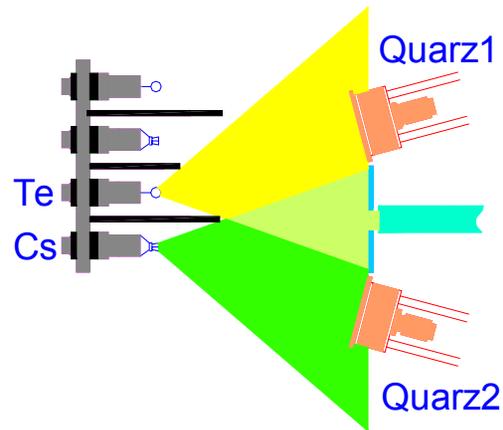
Classical evaporation process ; 8 MV/m ; DC gun measurement  
- Mean lifetime of 6 photo-cathodes, including high charge test

Classical evaporation process ; 105 MV/m ; CTF2 Drive Beam RF gun measurement, estimated working time with charge production : 1 working day over 2 , 8 hours / working day  
- Mean lifetime of 7 photo-cathodes

Co-evaporation process ; 8 MV/m ; DC gun measurement  
- No 137 : the first one, on new substrate  
- No 139: ICE



# Co-evaporation – 2 deposition rate monitors



Stöchiometrie

$$R = \frac{N_{Cs}}{N_{Te}} = \frac{2}{1}$$

## Calibration

Te, Cs separate

$$f_1^{Te} = \frac{S_1^{Te}}{S_c^{Te}}, \quad f_2^{Te} = \frac{S_2^{Te}}{S_c^{Te}}$$

$$f_1^{Cs} = \frac{S_1^{Cs}}{S_c^{Cs}}, \quad f_2^{Cs} = \frac{S_2^{Cs}}{S_c^{Cs}}$$

## Preparation

$$\dot{n}_{Te} = \frac{1}{D} (\dot{n}_2 f_2^{Cs} - \dot{n}_1 f_1^{Cs})$$

$$\dot{n}_{Cs} = \frac{1}{D} (\dot{n}_2 f_1^{Te} - \dot{n}_1 f_2^{Te})$$

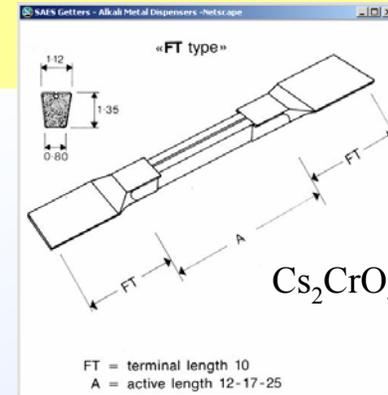
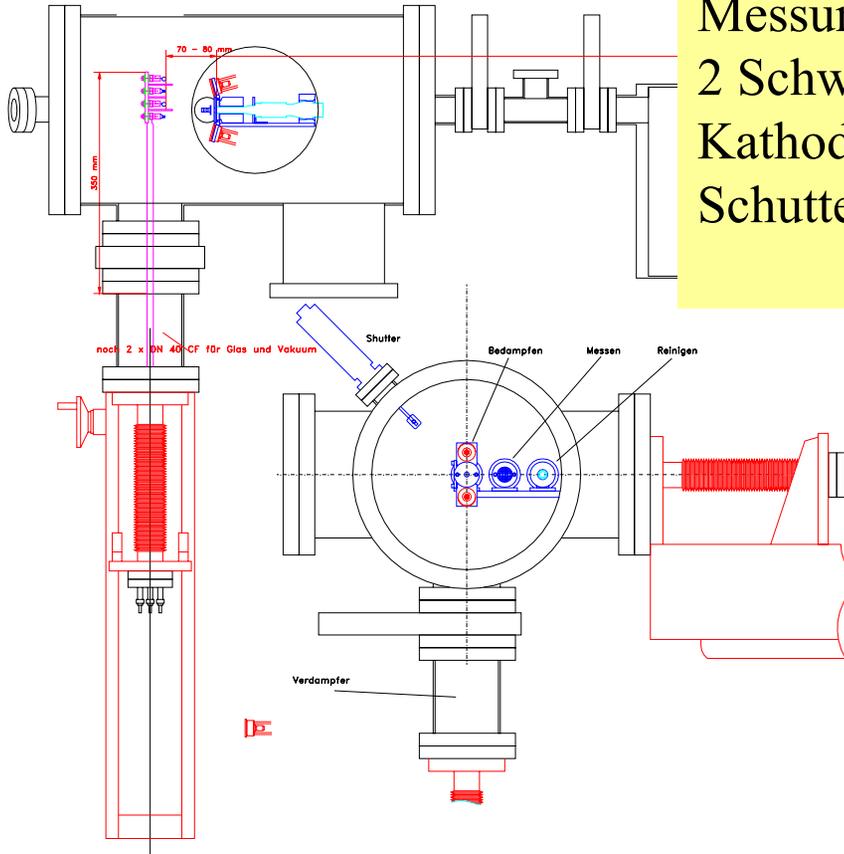
$$D = f_1^{Te} f_2^{Cs} - f_2^{Te} f_1^{Cs}$$

$$R = \frac{N_{Cs}}{N_{Te}} = \frac{M_{Te}}{M_{Cs}} \frac{\dot{n}_{Cs}}{\dot{n}_{Te}}$$

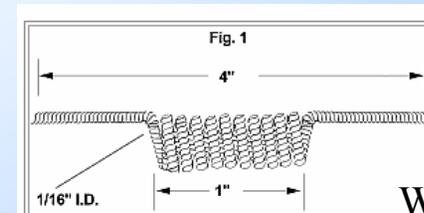
$$s = \frac{1}{\rho_{Cs2Te}} \int dt (\dot{n}_{Te} + \dot{n}_{Cs})$$

# Bedampfung

- Verdampfer für Te, Cs
- Kathodenhalter
- Blende (Lage und Größe des Cs<sub>2</sub>Te-Flecks)
- UV-Licht
- Messung des Photostroms
- 2 Schwingquarze zur Schichtdickenmessung
- Kathodenheizung und Temperaturmessung
- Shutter

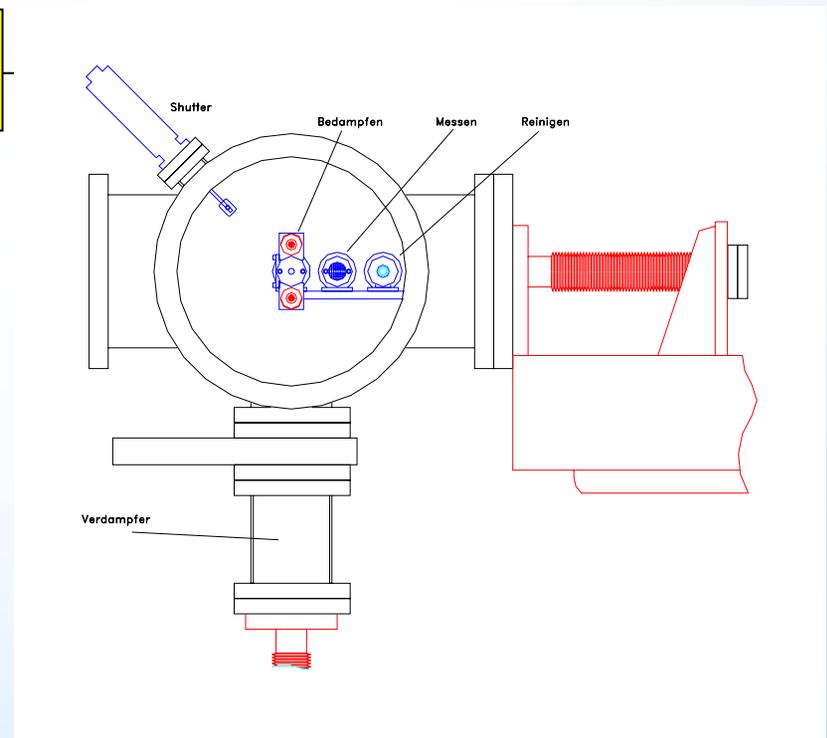
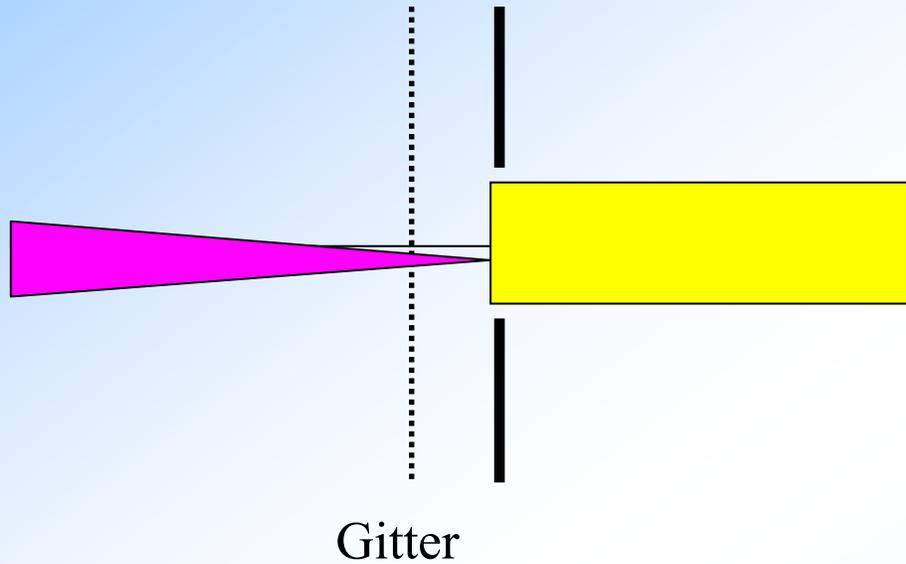


Cs<sub>2</sub>CrO<sub>4</sub> und Gettermaterial



W-Spirale für Te

# Messung der Q.E. - Laserscan



# Funktionsgruppen

- Kathodenwechsel
- Vakuumerzeugung und Messung
- Bedampfung
- Messung der Quantenausbeute
  - Laserscan
  - Absaugelektrode mit homogener Feldverteilung
  - Kathodenhalter
- Ionenstrahlreinigung
  - Kathodenhalter
  - Ionenquelle
- Was noch ? Diagnostik ?

# Gebäude 7

